

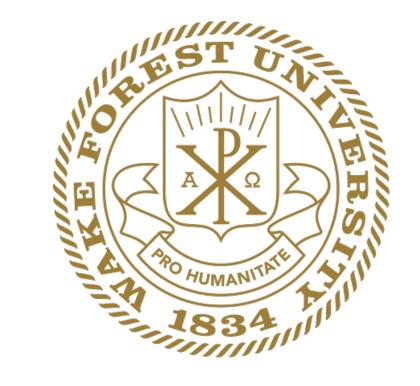
Generation of THz Electrical Pulses

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Abstract: Recently it has been shown that optical laser pulses can be used to manipulate the magnetism of various materials. Electrical pulses should be able to play the same role as optical pulses, but for this research to progress, the generation of THz electrical switches must first be studied. Using the epitaxial liftoff method, we transferred a low-temperature grown GaAs photoswitch onto a SiO₂ substrate, demonstrating the feasibility of this transfer method. We measured the carrier lifetime of the LT-GaAs, both before and after transfer onto quartz, and the electrical transient carried by Au conduction lines. We hope to build upon this work by demonstrating ultrafast all-electrical switching by means of the generated electrical pulse.

Eventual Goal

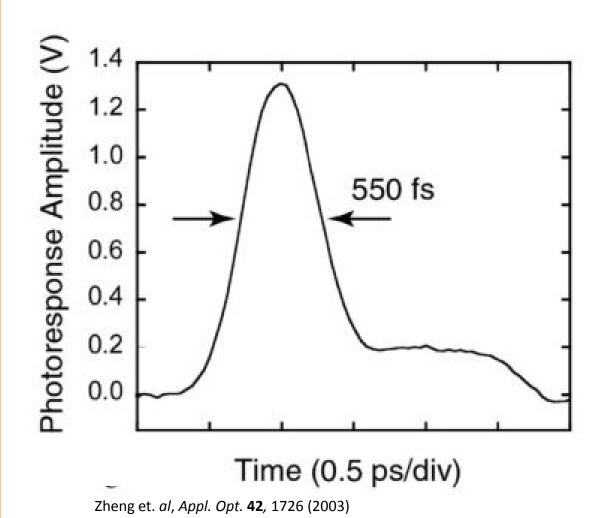
- Optical laser pulses have been shown to manipulate magnetism
- Want to use electricity as it is practical for devices -> need to generate of ultrafast electrical pulses

Objective

 Demonstrate feasibility of layer transfer and measure carrier lifetime electrical transients in different device geometries

Material: LT-GaAs

- Low temperature gallium arsenide III-V direct band gap semiconductor
- Grown in the temperature range 200 300° C by molecular beam epitaxy
- Defects are introduced -> limits carrier lifetime
- Electric pulse length is determined by carrier lifetime
- LT-GaAs cannot be grown on arbitrary substrates due to lattice mismatch



Fast intraband relaxation

Free electron

Fast non-radiative relaxation

Defect level

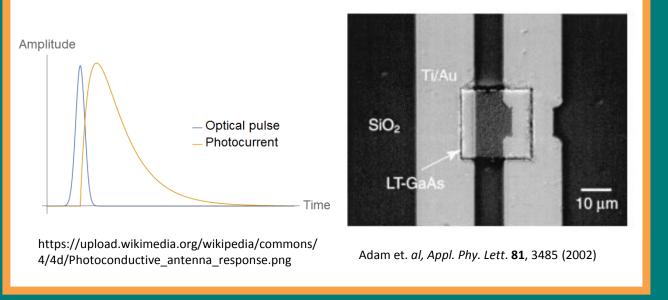
Wavevector k

Ev

http://www.batop.de/information/pictures/PCA band diagramme.png

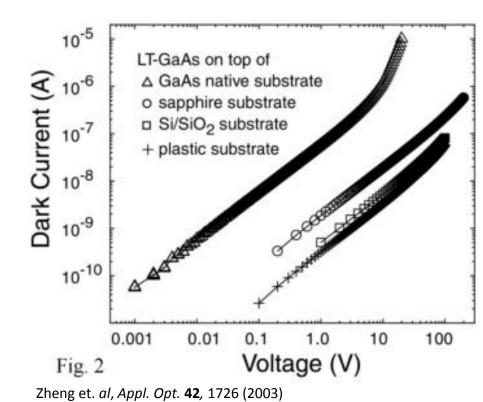
Auston Switch

- Generates electric pulse when excited by laser
- Transmission lines bridged by semiconductor
- Laser pulse creates electron/hole pairs in film
- DC voltage is applied across switch

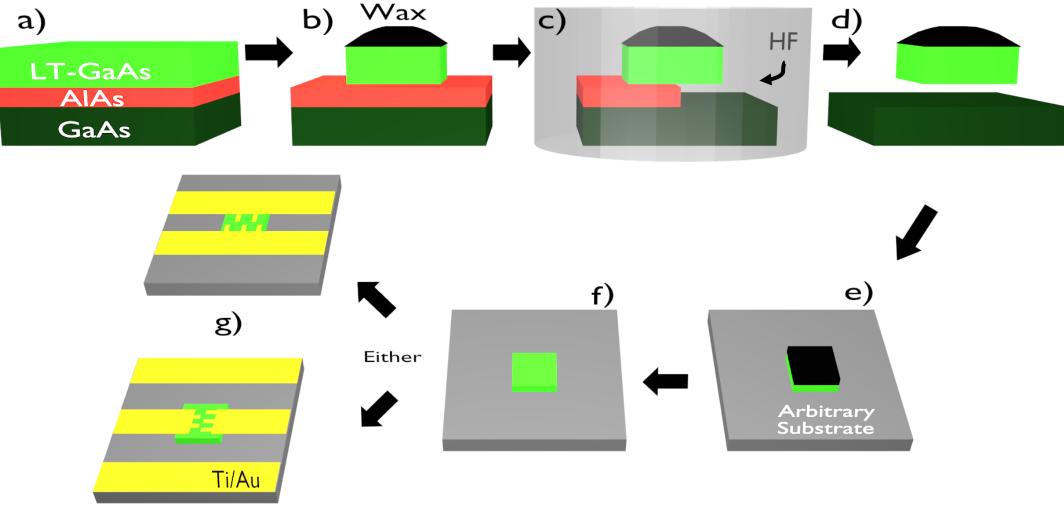


Layer Transfer

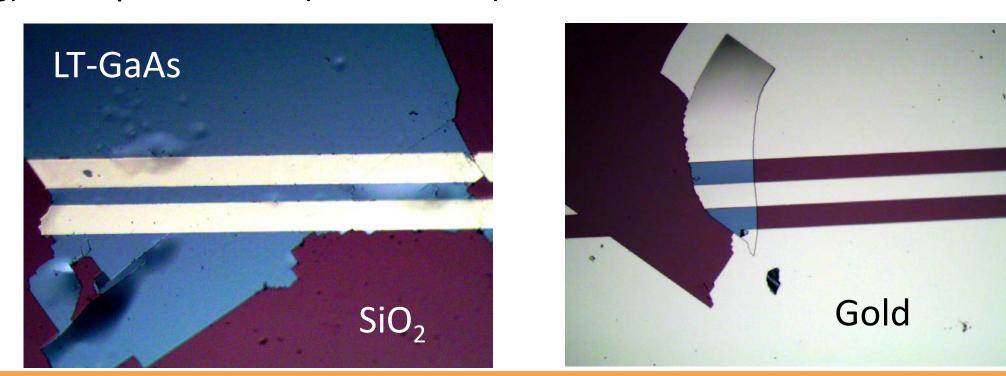
- Move LT-GaAs from growth substrate to arbitrary substrate using microfabrication techniques
- Allows for exploitation the properties of the new substrate



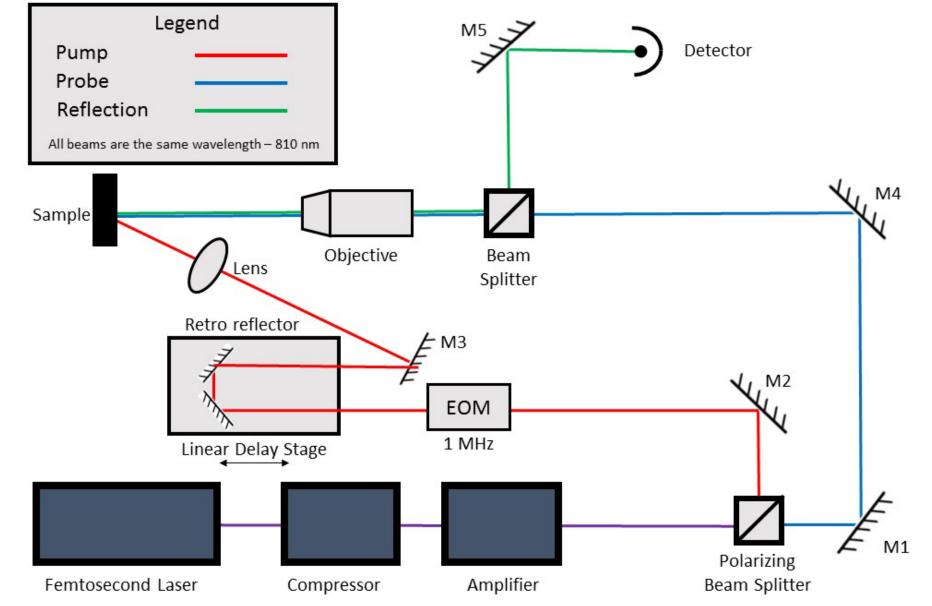
Fabrication



- a) GaAs/AlAs (500 nm)/LT-GaAs (2μm)
-) Pattern into small squares; coat with Apiezon W wax
- c) Etch AlAs using HF:H₂O (1:9) solution
- d) Transfer film using tweezers
- e) Bond film to SiO₂ substrate using VDW forces
- f) Dissolve wax in trichloroethylene
- g) Deposit Ti/Au (50/200 nm) transmission lines

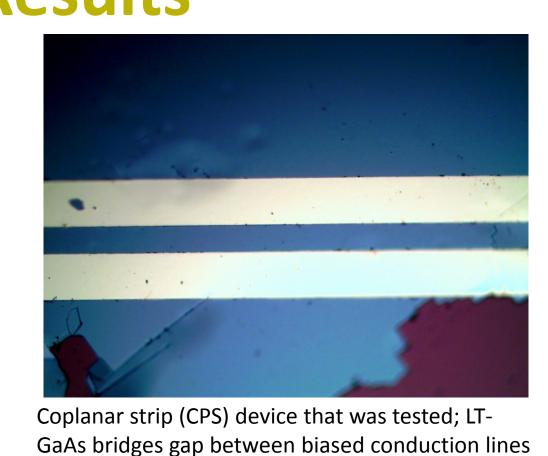


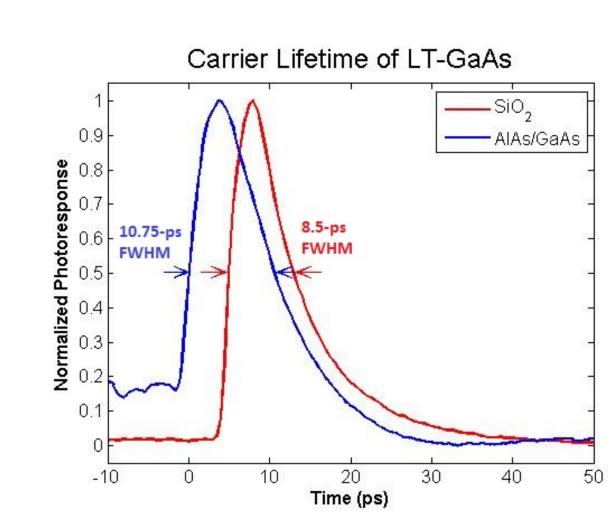
Optical Measurement



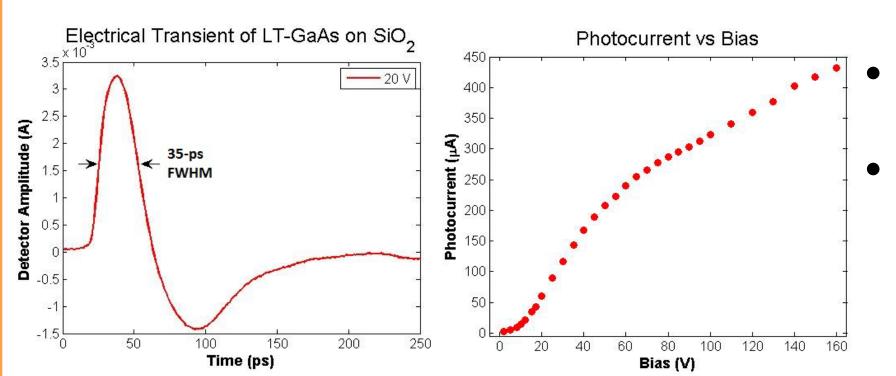
 GaAs detector can be used to measure electrical pulse transmitted by gold conduction lines

Results





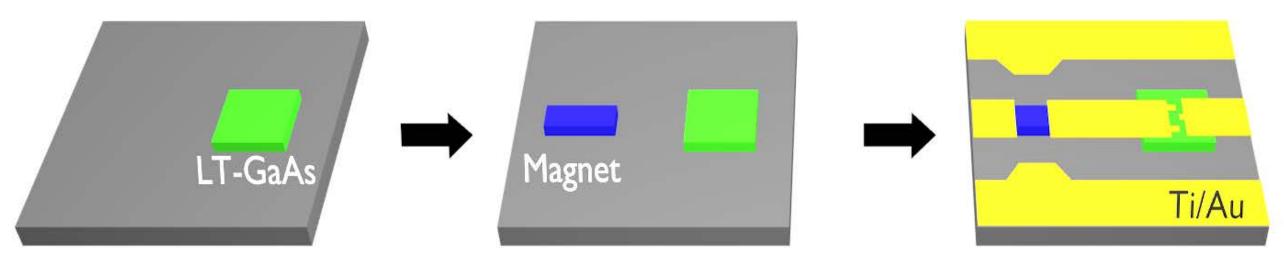
- Carrier Lifetime is 2.25 ps shorter after transfer
- Due to dielectric nature of SiO2, long-term energy dynamics are suppressed
- Dark current negligible for moderate voltages; < 30 nA at high voltages
- Electrical transient is x3 broader than carrier lifetime



- Breakdown of switch occurred at 170 V
- Nearly linear relationship between photocurrent and voltage

Future Work

- Improve fabrication process etch wells into SiO₂ to reduce height difference between switch and substrate -> reduce breaks in gold lines; use vacuum pipet to handle film instead of tweezers -> prevent cracks
- Direct electric pulse into magnet to attempt all-electrical switching



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